

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed: February 16, 2001

For: Integrated Semiconductor
Substrate Bevel Cleaning
Apparatus and Method

Group Art Unit: 1763

Examiner: Sylvia MacArthur

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (703) 872-9310 to the attention of the named Examiner, on the date below.

8/27/03

Date

Signature

REPLACEMENT RESPONSE TO OFFICE ACTION DATED FEBRUARY 26, 2003

In response to the Office Action dated February 26, 2003, having a shortened statutory period for response extended by a one month extension filed by Applicants and a Notice of Non-Compliant Amendment to expire on September 1, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Applicants submit this Replacement Response to Office Action Dated February 26, 2003 in response to the Notice of Non-Compliant Amendment dated August 1, 2003. This replacement response corrects the deficiency by including a marked-up copy of the amendments to the specification and claims. Although Applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/4969/CMP/ECP/NAN, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper. **Remarks** begin on page 8 of this paper.

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